

FIGURE 1

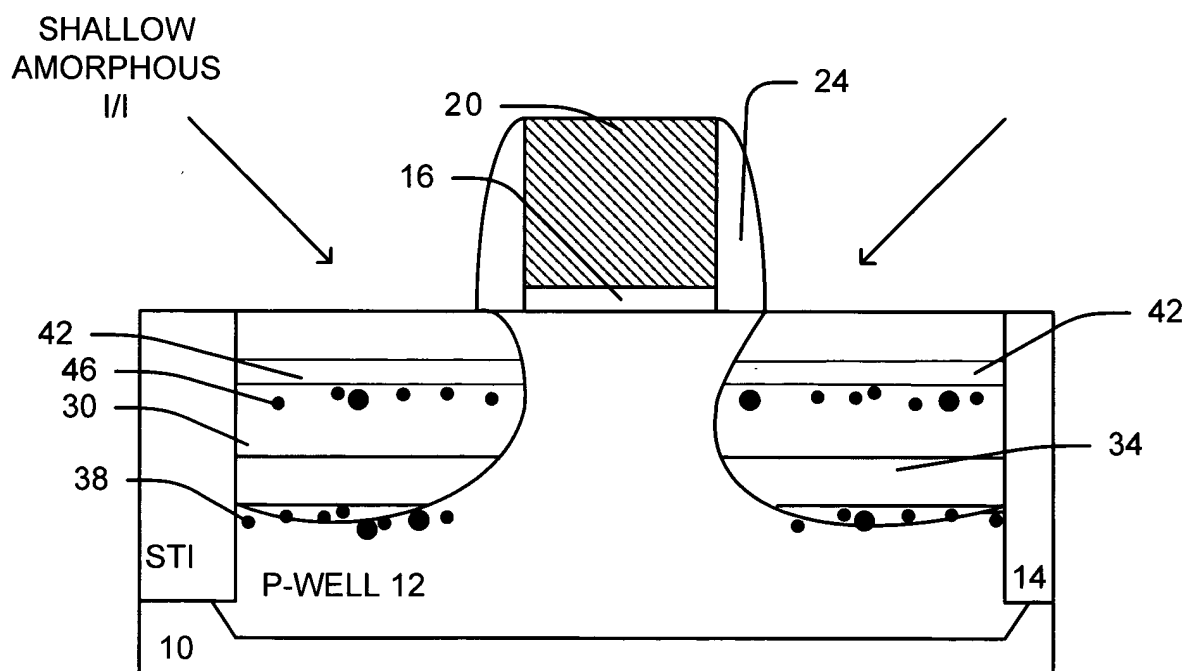


FIGURE 2

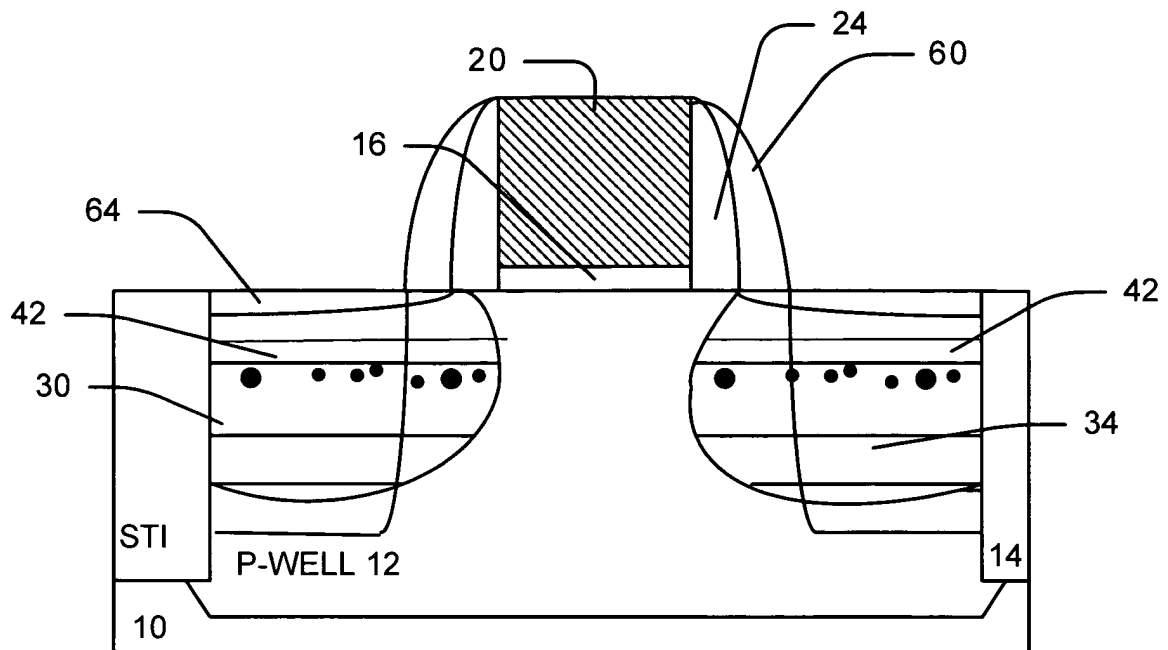


FIGURE 3A

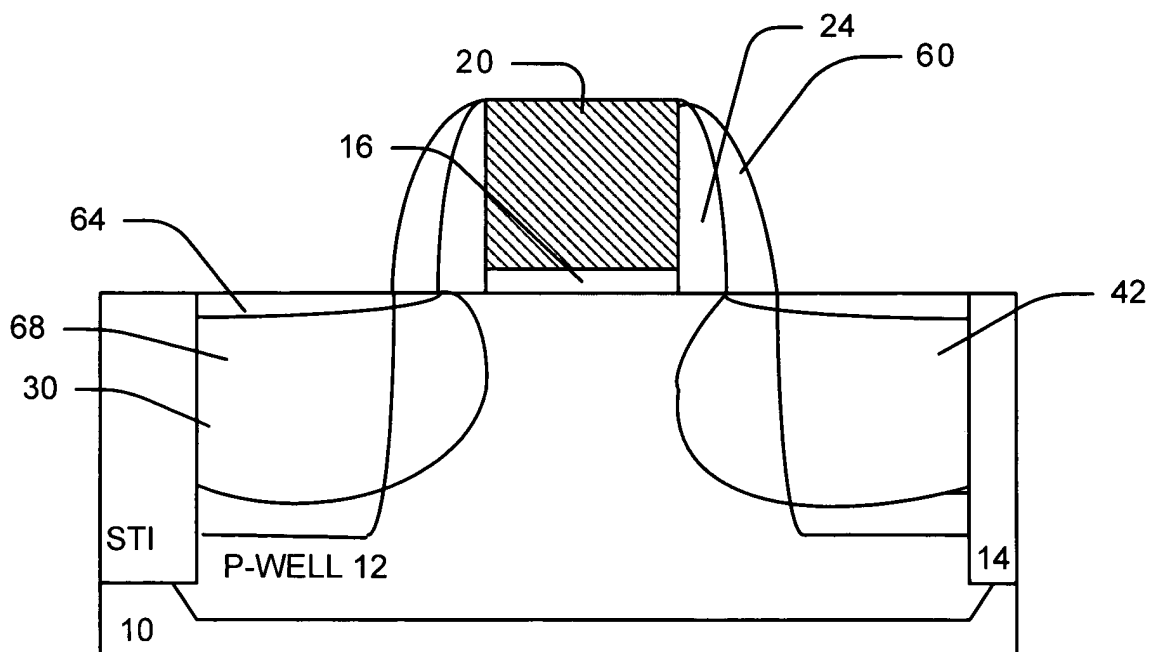


FIGURE 3B

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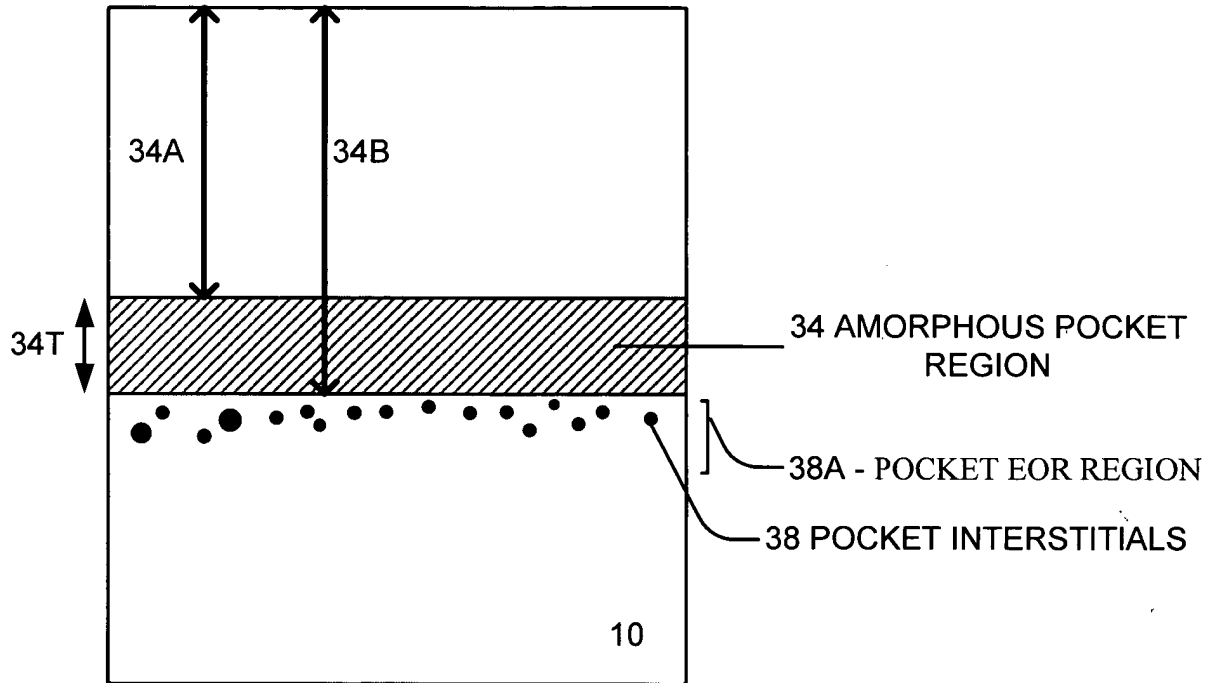


FIGURE 4A

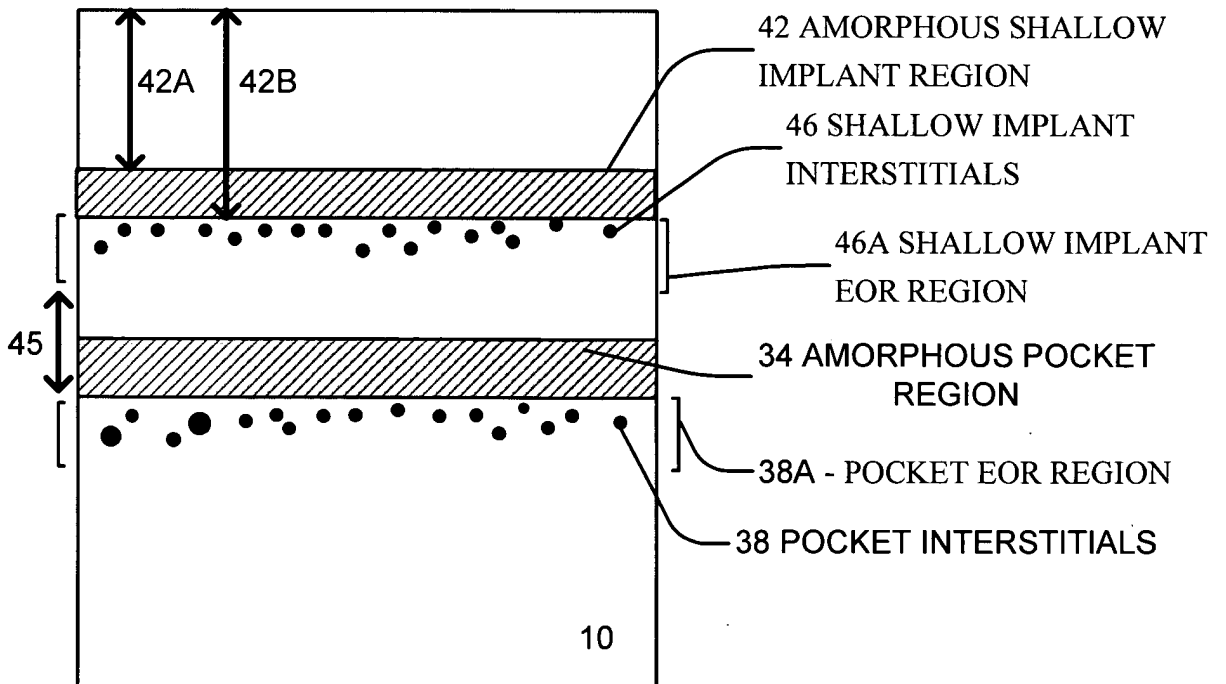


FIGURE 4B

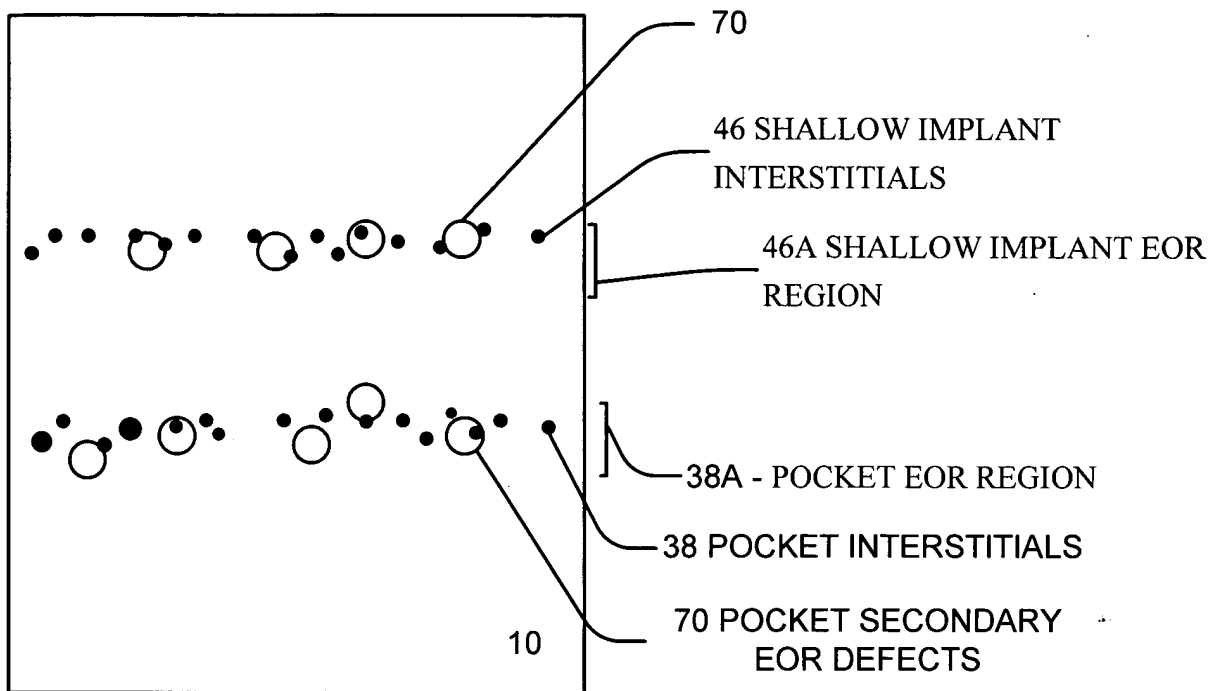


FIGURE 4C

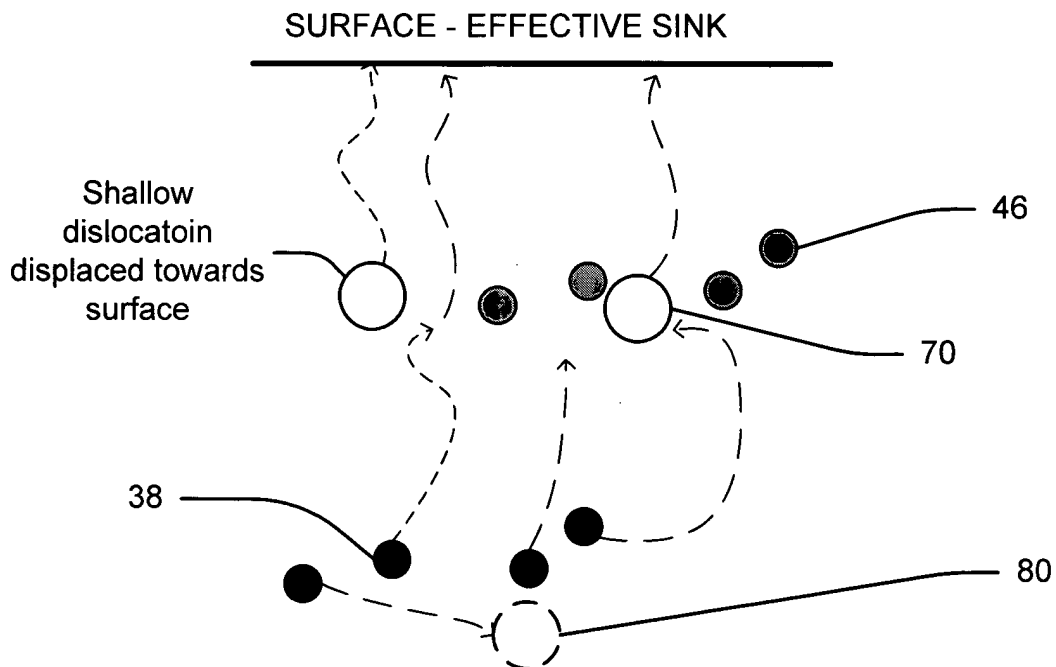


FIGURE 4D

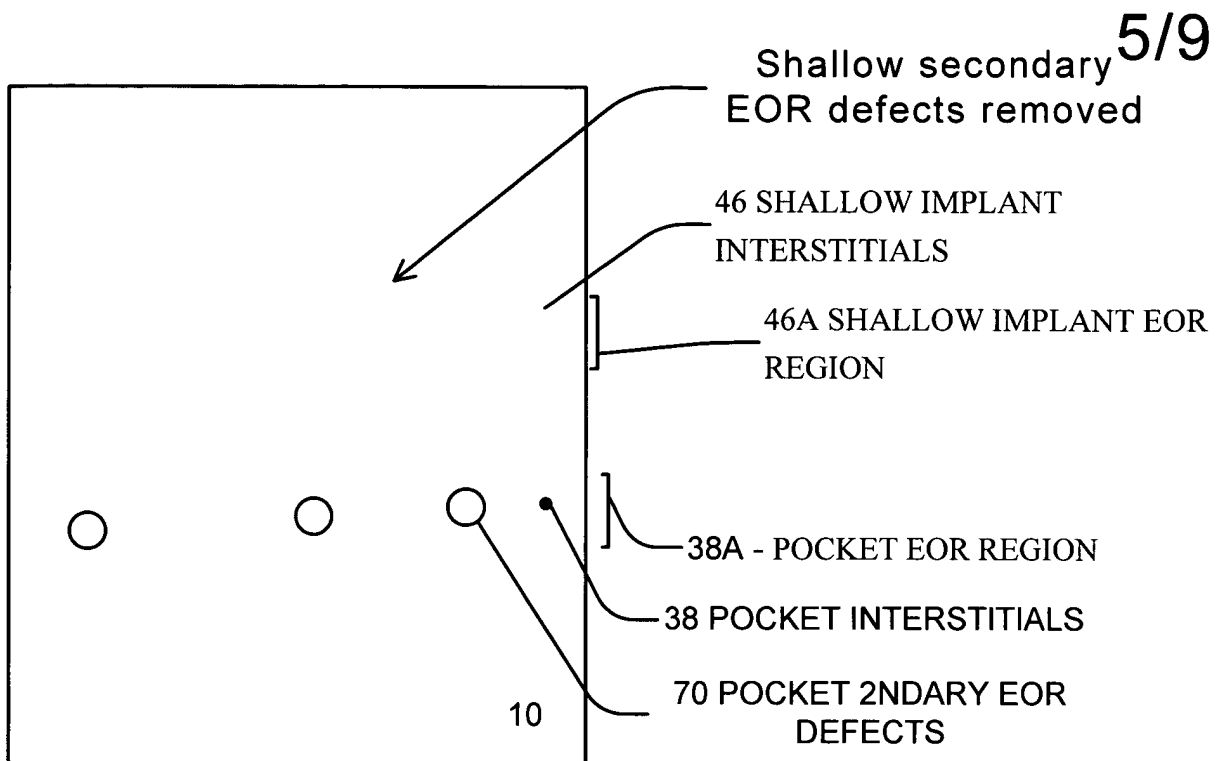


FIGURE 4E

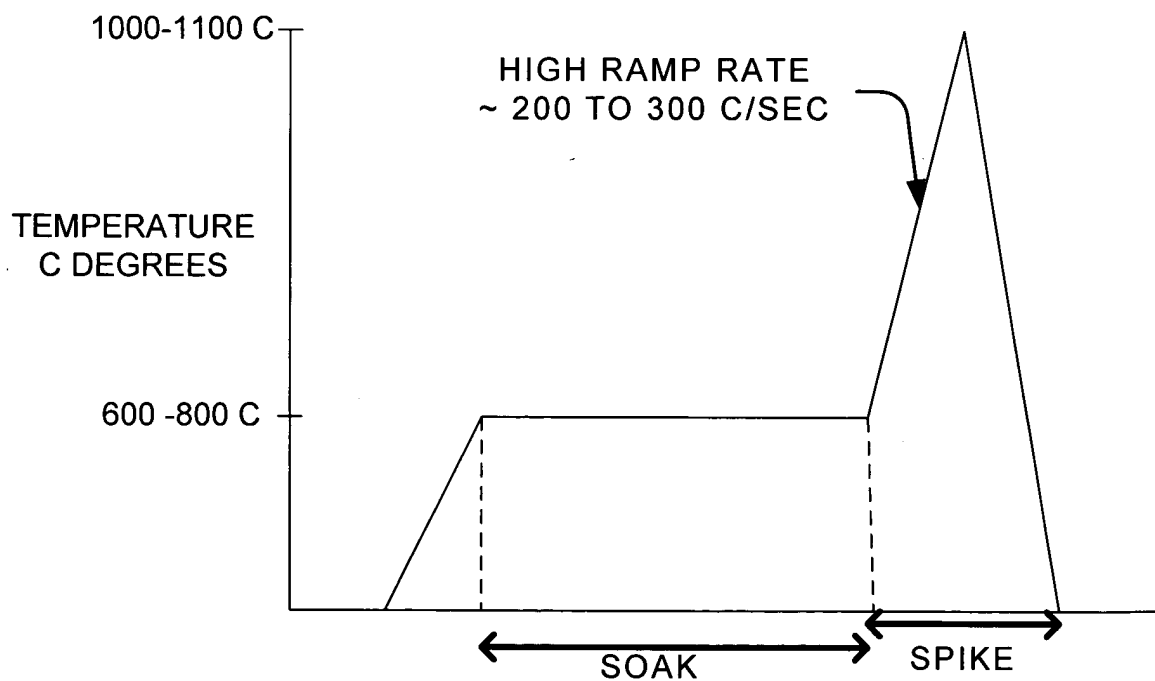


FIGURE 5

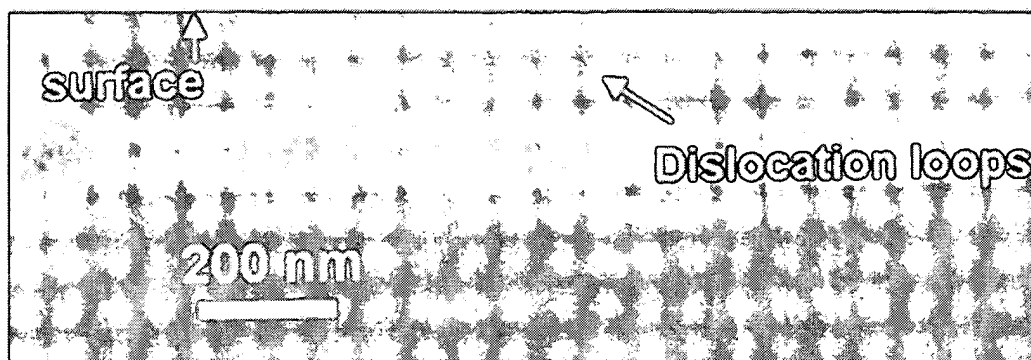


FIGURE 6A

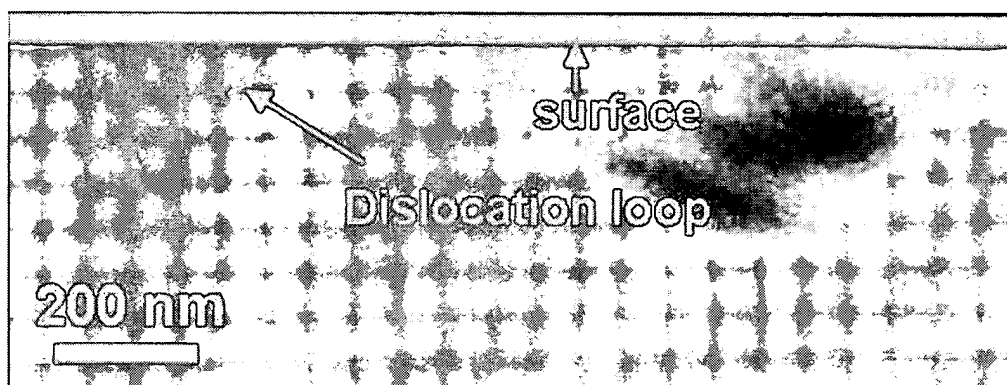


FIGURE 6B

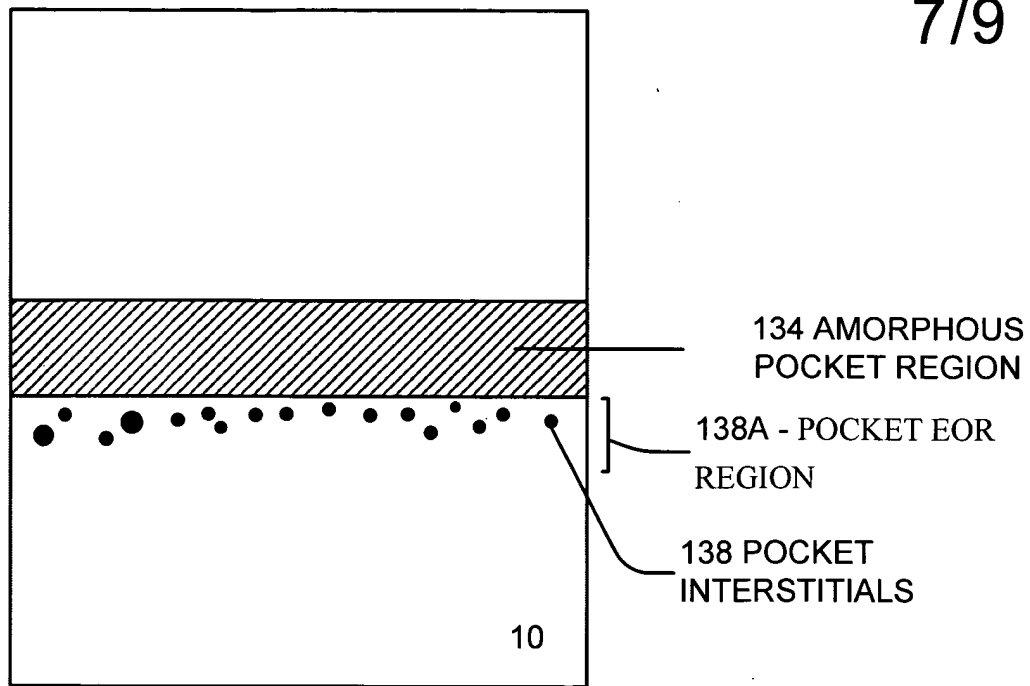


FIGURE 7A

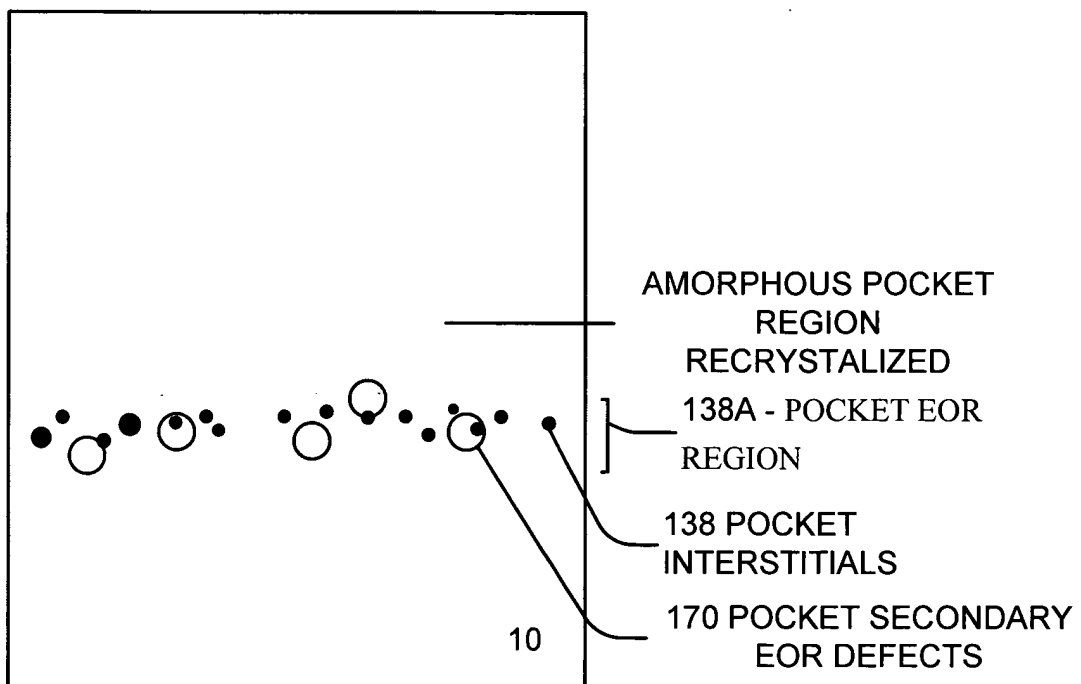


FIGURE 7B - POST SOAK ANNEAL

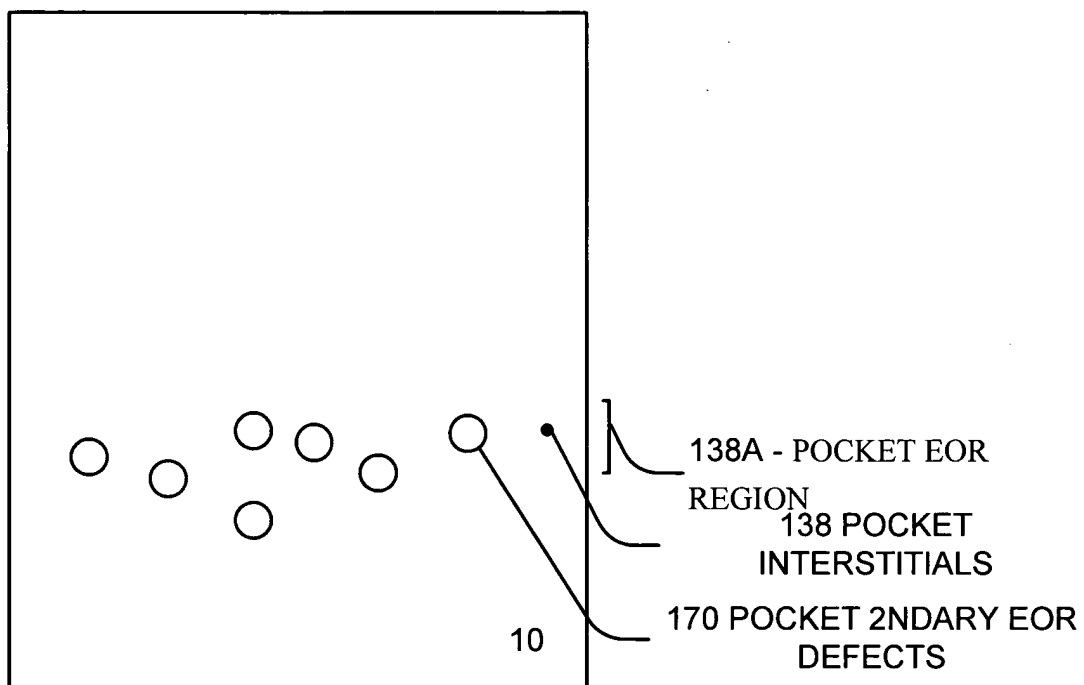


FIGURE 7C- POST SPIKE ANNEAL

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IONS BEING IMPLANTED

Si SUBSTRATE

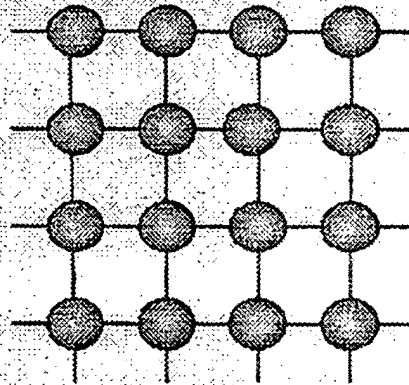
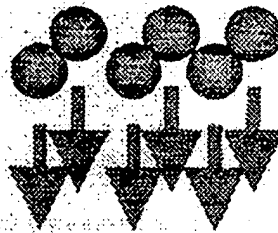


FIGURE 8A
PRIOR ART

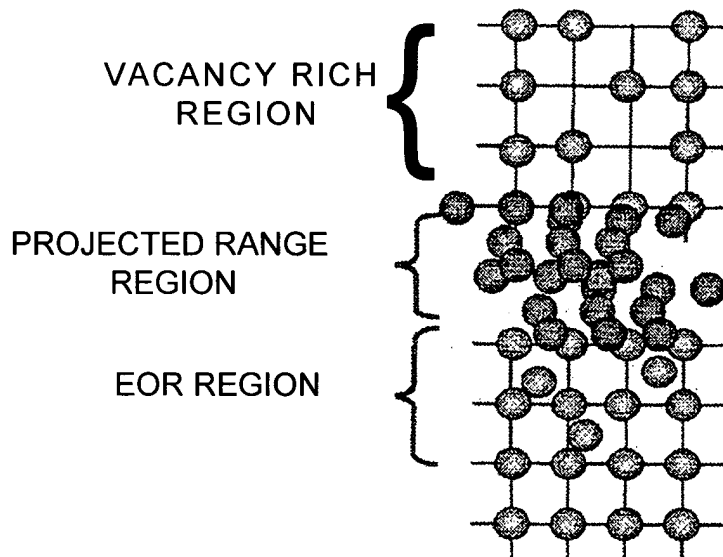


FIGURE 8B
PRIOR ART